PATENT APPLICATION

03500.016017.

AUG 2 7 2002 년	
re Application of: Examiner: KENELT PIERRE	
KATSUHISA MOCHIZUKI)	
## Group Art Unit: 2822 ## ## ## ## ## ## ## ## ## ## ## ## #	স
Filed: December 7, 2001	RECE
For: FLEXIBLE WIRING FILM, AND) SEMICONDUCTOR APPARATUS AND : SYSTEM USING THE SAME) Date: August 26, 2002	IVED

Commissioner for Patents Washington, D.C. 20231

SUBMISSION OF PRIORITY DOCUMENT

Sir:

In support of Applicant's claim for priority under 35 U.S.C. § 119, enclosed is a certified copy of the following Japanese application:

2000-380572 filed December 14, 2000

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicant

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